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IE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Jong Jin Park et al.

Application No.: 10/814,264

Filing Date:

April 1, 2004

Group Art Unit: Unassigned

Examiner: Unassigned

Confirmation No.: Unassigned

Title: PHOTOSENSITIVE SEMICONDUCTOR NANOCRYSTALS, PHOTOSENSITIVE COMPOSITION

COMPRISING SEMICONDUCTOR NANOCRYSTALS AND METHOD FOR FORMING

SEMICONDUCTOR NANOCRYSTAL PATTERN USING THE SAME

FIRST INFORMATION DISCLOSURE STATEMENT TRANSMITTAL LETTER

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIF:					
	closed is a			closure Statement and	accompanying form
×	No additional f	ee for submiss	ion of an IDS is requ	uired.	
			•	.R. § 1.17(p) is also er	nclosed.
			§ 1.97(e) is also en		
		nder 37 C.F.R.			as set forth in 37 C.F.R
	Charge	to Dep	osit Account No. 02	-4800 for the fee due.	
			is enclosedit card. Form PTC		
1.21 tha	e Director is here at may be require per is submitted	ed by this paper	to charge any appro r, and to credit any o	priate fees under 37 Coverpayment, to Depos	C.F.R. §§ 1.16, 1.17 and sit Account No. 02-4800
			Resp	ectfully submitted,	
			BUR	NS, DOANE, SWECKI	ER & MATHIS, L.L.P.
P.O. Bo					
	dria, Virginia 223	13-1404		\sim 2 \circ	
(703) 83	36-6620		Ву	S-D. Boone	Req. No. 52,635
				Charles F. Wieland III	
Date: N	//arch 1, 2005			Registration No. 33,0	96



INITED STATES PATENT AND TRADEMARK OFFICE

In re F	Patent Application of	
Jong .	Jin Park et al.	Group Art Unit: Unassigned
Applic	ation No.: Unassigned	Examiner: Unassigned
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For:	PHOTOSENSITIVE SEMICONDUCTOR NANOCRYSTALS, PHOTOSENSITIVE COMPOSITION COMPRISING SEMICONDUCTOR NANOCRYSTALS AND METHOD FOR PORMING SEMICONDUCTOR NANOCRYSTAL PATTERN USING THE SAME	

FIRST INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, the accompanying information is being submitted in accordance with 37 C.F.R. §§ 1.97 and 1.98.

To assist the Examiner, the document is listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

Date <u>March 1, 2005</u>

3y: ____<u>>-</u>

Reg. No. 52,635

Charles F. Wieland III Registration No. 33,096

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	(use as man	y sheets a	s necessary)
Sheet	1	of	1

Complete if Known					
Application Number	10/814,264				
Filing Date	April 1, 2004				
First Named Inventor	Jong Jin Park et al.				
Examiner Name					
Attorney Docket Number	021269-013				

	U.S. PATENT DOCUMENTS					
Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)		
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	STATUS										
Examiner Initials	Document Number	Kind Code (if known)	Country	Date of Publication (MM-DD-YYYY)	Translation	Partial Translation	Eng. Lang. Summary	Search Report	IPER	Abstract	Cited in Spec
7 3									FA		
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	NON-PATENT LITERATURE DOCUMENTS					
Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.					
	*M. COLOCCI ET AL., "Growth patterns of self-assembled InAs quantum dots near the two-dimensional to three-dimensional transition", Appl. Phys. Lett. 70, Vol. 23, 9 June 1997, pp. 3140-3142					
*Copy att	ached					

Examiner Signature

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.